

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kenichi SHIRAISHI

Group Art Unit: 2852

Application No.: 10/588,146

Filed: August 1, 2006

Docket No.: 128985

For: EXPOSURE APPARATUS, DEVICE MANUFACTURING METHOD, MAINTENANCE METHOD, AND EXPOSURE METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of one or more non-English language reference is discussed in the present specification. See References 12-24.
- ☒ 3. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 4. An English language Abstract of one or more non-English language reference is attached hereto. See References 12-24.

- ☒ 5. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 12, 14 and 16-24.

Respectfully submitted,



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Date: January 4, 2007

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AUTHORIZATION**

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Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 128985		APPLICATION NO. 10/588,146	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Kenichi SHIRAISHI			
				FILING DATE August 1, 2006		GROUP 2852	
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
	1	US 2004/0020782 A1	02/05/2004	Cohen et al.			
	2	US 6,341,007 B1	01/22/2002	Nishi et al.			
	3	US 6,400,411 B1	06/04/2002	Bayes et al.			
	4	US 6,549,269 B1	04/15/2003	Nishi et al.			
	5	US 6,591,634 B1	07/15/2003	Morizane			
	6	5,969,441	10/19/1999	Loopstra et al.			
	7	US 6,208,407 B1	03/27/2001	Loopstra			
	8	5,825,043	10/20/1998	Suwa			
	9	5,623,853	04/29/1997	Novak et al.			
	10	5,528,118	06/18/1996	Lee			
	11	5,874,820	02/23/1999	Lee			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
	12	JP A 08-37149	02/06/1996	Japan	X	X	
	13	JP A 04-65603	03/02/1992	Japan	X		
	14	JP A 07-176468	07/14/1995	Japan	X	X	
	15	JP A 57-117238	07/21/1982	Japan	X		
	16	JP A 2002-14005	01/18/2002	Japan	X	X	
	17	JP A 11-16816	01/22/1999	Japan	X	X	
	18	JP A 06-188169	07/08/1994	Japan	X	X	
	19	JP A 10-163099	06/19/1998	Japan	X	X	
	20	JP A 10-214783	08/11/1998	Japan	X	X	
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: January 4, 2007

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FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
	21	JP A 2000-505958	05/16/2000	Japan	X	X	
	22	JP A 06-124873	05/06/1994	Japan	X	X	
	23	JP A 08-166475	06/25/1996	Japan	X	X	
	24	JP A 08-330224	12/13/1996	Japan	X	X	
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
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